

INTERNATIONAL SEARCH REPORT

International application No.

PCT/JP2004/011325

A. CLASSIFICATION OF SUBJECT MATTER
Int.Cl' C01B31/30, C23C8/02, C23C8/20

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHEDMinimum documentation searched (classification system followed by classification symbols)
Int.Cl' C01B31/30, C23C8/02, C23C8/20

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Jitsuyo Shinan Koho	1922-1996	Toroku Jitsuyo Shinan Koho	1994-2004
Kokai Jitsuyo Shinan Koho	1971-2004	Jitsuyo Shinan Toroku Koho	1996-2004

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)
JICST, WEB OF SCIENCE, SCIENCE DIRECT: tantalum carbide, tantalum oxide, Ta₂O₅, Ta₂C, TaC, sublimation, carbonization**C. DOCUMENTS CONSIDERED TO BE RELEVANT**

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	JP 06-049619 A (Leybold Durferrit GmbH.), 22 February, 1994 (22.02.94), Full text & EP 544987 A1 & US 5372655 A	1-15
A	ROCHER M. et al., Modelling of the growth of carbide layers in tantalum, KEY.ENG. MATER., 2002, Vol.206/213, No. Pt.1, pages 527 to 530	1-15
A	KHARATYAN S.L. et al., Kinetics of tantalum carbidization, SOV.J.CHEM.PHYS., 1991, Vol.8, No.8, pages 1881 to 1892	1-15

 Further documents are listed in the continuation of Box C. See patent family annex.

* Special categories of cited documents:	
"A"	document defining the general state of the art which is not considered to be of particular relevance
"E"	earlier application or patent but published on or after the international filing date
"L"	document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
"O"	document referring to an oral disclosure, use, exhibition or other means
"P"	document published prior to the international filing date but later than the priority date claimed
"T"	later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"X"	document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
"Y"	document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
"&"	document member of the same patent family

Date of the actual completion of the international search
02 November, 2004 (02.11.04)Date of mailing of the international search report
16 November, 2004 (16.11.04)Name and mailing address of the ISA/
Japanese Patent Office

Authorized officer

Facsimile No.

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C (Continuation). DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	TAKAHIRO TSUTSUMOTO, Improvement of Ta filament for diamond CVD, THIN SOLID FILMS, 1998, Vol. 317 to 375	1-15
A	US 5383981 A (THE UNITED STATES OF AMERICA AS REPRESENTED BY THE UNITED STATES DEPARTMENT OF ENERGY), 24 January, 1995 (24.01.95), Full text (Family: none)	1-15
A	JP 56-079449 A (Mitsubishi Electric Corp.), 30 June, 1981 (30.06.81), Claims & DE 3044388 A & US 4333226 A	1-15